Express Mail No. EU190394624US Attorney Docket No.: AM-3467.C1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Eric Ou-Yang et al.

§ GROUP ART UNIT: 1746

SERIAL NO.: 10/080,882

EXAMINER: Unknown

FILED: February 21, 2002

FOR: HIGH DENSITY PLASMA POST-ETCH TREATMENT

FOR A DIELECTIC ETCH PROCESS.

Attorney Docket No.: AM-3467.C1

RECEIVED, TC 1700

Date: June 4, 2002

INFORMATION DISCLOSURE STATEMENT TRANSMITTAL LETTER

Hon. Commissioner for Patents Washington, DC 20231

Sir:

Applicants are submitting the subject Information Disclosure Statement under 37 CFR § 1.97(b)(3). This Information Disclosure Statement is being submitted prior to the first Office Action in the subject application.

CERTIFICATE OF MAILING UNDER 37 CFR § 1.10

I hereby certify that this paper is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. EU190394624US in an envelope addressed to the: Commissioner for Patents, Box DD, Washington, DC 20231.

Date: June 4, 2002

Shirley L. Church, Reg. No. 31,858

Applicants do not believe that any fee is due in connection with the filing of this Information Disclosure Statement under 37 CFR § 1.97(b)(3). However, in the event that any additional fee is due, the Commissioner is hereby authorized to charge Deposit Account No. 50-1512 of Shirley L. Church, Sunnyvale, California, in the amount of such fee.

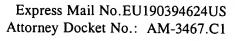
This transmittal letter is submitted in duplicate for accounting purposes.

Respectfully submitted,

Shirley Z. Church
Shirley L. Church

Registration No. 31,858 Attorney for Applicants

Correspondence Address:
Patent Counsel
Applied Materials, Inc.
P.O. Box 450-A
Santa Clara, California 95052





IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Eric Ou-Yang et al.

SERIAL NO.: 10/080,882

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TITLE:

HIGH DENSITY PLASMA POST-ETCH

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INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §1.97(b)(3)

Hon. Commissioner of Patents and Trademarks Washington, DC 20231

Sir:

In accordance with 37 CFR § 1.97(b)(3), applicants hereby request consideration of this Information Disclosure Statement. Applicants are providing herewith copies of the items listed on the attached U.S. Patent and Trademark Office form PTO-1449 equivalent. This Information Disclosure Statement is being submitted prior to the first Office Action in the subject application.

CERTIFICATE OF MAILING UNDER 37 CFR § 1.10

I hereby certify that this paper is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. Express Mail No. EU190394624US in an envelope addressed to the: Commissioner for Patents, Box DD, Washington, DC 20231 on June 4, 2002.

Shirley L. Church, Esq., Reg. No. 31,858

Express Mail No.EU190394624US Attorney Docket No.: AM-3467.C1

The submission of this Information Disclosure Statement and Form PTO-1449 is not an admission that the art cited is "prior art" with respect to the present invention, nor is it a representation that no better art exists. Applicants hereby reserve the right to swear behind or otherwise disprove any alleged "prior" nature of any art cited should the facts support and the situation warrant such an action.

Respectfully Submitted,

Shirley L. Church, Esq. Registration No. 31,858

Attorney for Applicant (408) 245-5109

Correspondence Address: Patent Counsel Applied Materials, Inc. P.O. Box 450 A

Santa Clara, CA 95052

Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Cite No. ¹	Kind		Name of Cotonton on Annii		T
	U.S. Patent Document Kind Code ² (if known)		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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FOREIGN PATENT DOCUMENTS								
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Examiner Initials*	Cite No. ¹	Office ³	Number⁴	Kind Code ⁵ (<i>if known</i>)	or Applicant of Cited Document	Cited Document MM-DD-YYYY	Where Relevant Passages or Relevant Figures Appear	T ₆
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Sheet 2 of 2

	Complete if Known	
Application Number	10/080,882	11.
Filing Date	February 21, 2002	a ON,
First Named Inventor	Eric Ou-Yang et al.	
Group Art Unit	1746	7 100
Examiner Name		
Attorney Docket Number	AM-3467.C1	
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	OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS				
Examiner Initials *	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²		
		United States Patent Application: "Method of Reducing Stop Layer Loss in a Photoresist Stripping Process Using Hydrogen as a Flourine Scavenger." Serial No.: 09/183,778.			

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Examiner		
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